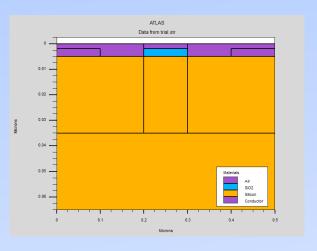
# Simulation and Comparison of MOSFETs with Different Channel Materials

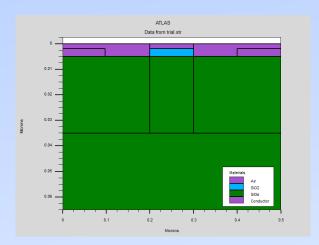
Using Silvaco TCAD Si, Ge & SiGe MOSFETs

## **Project Objective and Tools Used**

- Objective:
- To simulate and compare the I-V characteristics of MOSFETs with different channel materials:
- - Silicon (Si)
- Germanium (Ge)
- Silicon-Germanium (SiGe)
- Tools Used:
- Silvaco ATLAS (TCAD)
- - TonyPlot (Visualization)

### **MOSFET Structures in Silvaco TCAD**



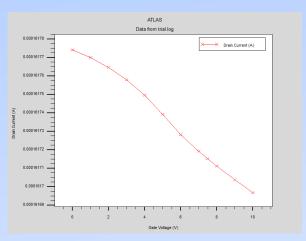


Silicon Structure

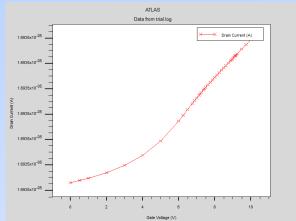
Germanium Structure

Si-Ge Structure

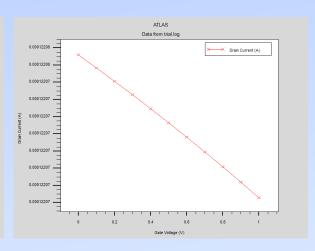
#### **I-V Characteristics of Simulated MOSFETs**



IV Characteristic for Silicon



IV Characteristic for Germanium



IV Characteristic for Si-Ge

## **Comparison and Key Observations**

- Drain Current Performance:
- Ge MOSFET shows highest current due to better carrier mobility.
- SiGe MOSFET balances performance and leakage.
- Si MOSFET has the lowest current but stable performance.
- Applications Insight:
- SiGe may be more suitable for low-power, high-performance designs.
- Ge offers high-speed benefits but with thermal/leakage tradeoffs.

## **Conclusion**

 Successfully simulated and analyzed MOSFETs with Si, Ge, and SiGe channels using Silvaco TCAD.

 Simulation results show how material choice significantly impacts electrical characteristics of devices.

 This study reinforces the importance of TCAD in evaluating semiconductor design options before fabrication.